INFORMATION DISCLOSURE CATATION

Docket Number (Optional) END9-2000-	Application Number	
Applicant(s) Ballantine et al.	b Usor	
Filing Date	Group Art Unit	

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Ballantine et al. (Use several sheets if necessary) FILING GROUP U.S. PATENT DOCUMENTS **EXAMINER** DOCUMENT NUMBER FILING DATE DATE NAME CLASS SUBCLASS INITIAL IF APPROPRIATE **FOREIGN PATENT DOCUMENTS** TRANSLATION DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS YES OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) T.A. Kuku, "ION TRANSPORT STUDIES ON VACUUM DEPOSITED PbSnI4 THIN FILMS,"; Thin Solid Films V 340 N1 1999 P 292-296 Gregor, L.V., "THIN FILM VOLTAGE SOURCE,"; IBM Technical Disclosure Bulletin, Nov 1964, P 433 **EXAMINER DATE CONSIDERED** *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Form PTO-A820 (also form PTO-1449)

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